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Attorney Docket No. 033773M053

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Kouichi Yamima, et al.

Examiner: To Be Assigned

Serial No. : 10/694,179

Filed: October 28, 2003

Group Art Unit: 1765

For: METHOD OF PRODUCING A SEMICONDUCTOR WAFER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in an Austrian Search Report provided to the Singapore Registrar of Patents and issued for counterpart Singapore Patent Appln. No. 200306448-2 mailed March 2, 2005. According to the Search Report, U.S. Patent No. 6,448,151 is a family member of U.S. Publication No. 2002/016047.

It is believed that each item of information contained in this Information Disclosure Statement should be considered to have been cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. In any event, no fees are believed to be due because no office actions have yet issued for this case.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of

record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
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APPLICANT:

Kouichi Yamima, et al.

FILING DATE
October 28, 2003GROUP ART UNIT
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U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA	2002/0016047	2/7/02	Tateishi			
	AB	5,491,461	2/13/96	Partin et al.			
	AC	6,448,151	9/10/02	Tateishi			
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
	AH	09-134893	5/20/97	Japan			Abstract Only	
	AI							
	AJ							
	AK							
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ							
	AR							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AS	
	AT	

EXAMINER:

DATE CONSIDERED:

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.